

OK TO ENTER: /A.S./ (05/17/2011)

DOCKET NO: 230421US26YA

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
ANDREJ S. MITROVIC : EXAMINER: AKASH SAXENA
SERIAL NO: 10/673,501 :
FILED: SEPTEMBER 30, 2003 : GROUP ART UNIT: 2128
FOR: SYSTEM AND METHOD FOR :
USING FIRST-PRINCIPLES
SIMULATION TO CHARACTERIZE A
SEMICONDUCTOR MANUFACTURING
PROCESS

REQUEST FOR CORRECT INVENTORSHIP UNDER 37 C.F.R. §1.48(1)

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In the matter of the above-identified application, Applicant hereby request correction of your records to reflect the following change in inventorship. The omission of the second inventor was inadvertent and such omission occurred without deceptive intent. Please add the following inventor:

Eric J. STRANG
Residence: Chandler, Arizona
Citizenship: United States
Mailing Address: 1081 West Oriole Way, Chandler, Arizona 85248

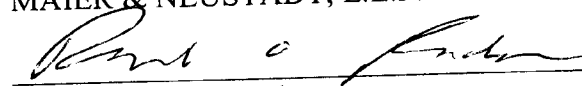
The processing fee set forth in § 1.17(i) is enclosed herewith.

Customer Number
22850

Tel: (703) 413-3000
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(OSMMN 07/09)

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.



Steven P. Weihrouch
Attorney of Record
Registration No. 32,829
Ronald A. Rudder, Ph.D.
Registration No. 45,618

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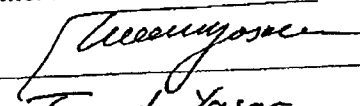
CONSENT OF ASSIGNEE UNDER 37 C.F.R. §1.48(a)(5)

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

On behalf of the Assignee, Tokyo Electron Limited, I consent that Eric J. STRANG
should be added as an inventor of the above-mentioned invention.

Date: 10/22/2010

Signature: 

Name: Taynut Yasar

Title: Vice President IP

(On behalf of Tokyo Electron)

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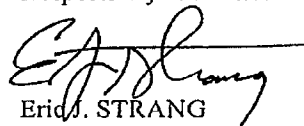
STATEMENT FROM THE INVENTOR UNDER 37 C.F.R. §1.48(c)(2)

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

I hereby state that I am a co-inventor of the above mentioned invention. My inventive contribution is necessitated by amendments which have been made to the claims. The inventorship error occurred without deceptive intent on my part.

Respectfully submitted


Eric J. STRANG
Inventor

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